



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In the application of

Docket No: Q81015

Shuho MOTOMURA

Appln. No.: 10/820,752

Group Art Unit: 1762

Confirmation No.: 8798

Examiner: Katherine A. Bareford

Filed: April 9, 2004

For: SUBSTRATE PROCESSING SYSTEM, COATING APPARATUS, AND COATING METHOD

**SUPPLEMENTAL RESPONSE UNDER 37 C.F.R. § 1.114(c)**

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination of the RCE filed March 19, 2007, please consider the supplemental remarks made on the accompanying pages.

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